

Docket No.: SON-2129/DIV  
(80001-2910)  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Divisional Patent Application of U.S.  
Application No.: 09/883,235

Examiner: J. Nguyen

Tsuyoshi TOJO, et al.

Art Unit: 2815

Application No.: Not Yet Assigned

Filed: November 25, 2003

For: SEMICONDUCTOR LASER

**CLAIM FOR PRIORITY AND SUBMISSION OF DOCUMENTS**

**MS PATENT APPLICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The benefit of the filing dates of the following prior applications filed in the following foreign country is hereby requested and the right of priority provided under 35 U.S.C. §119 is hereby claimed:

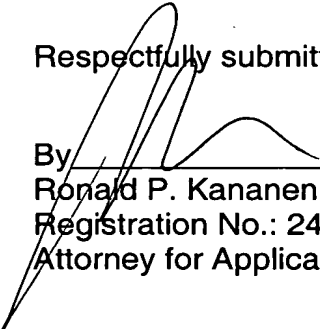
Japanese Patent Appl. No. P2000-183920, filed June 20, 2000

Japanese Patent Appl. No. P2000-207229, filed July 7, 2000

In support of this claim, filed within parent application Serial No. 09/883,235 is a certified copy of said original foreign applications.

Dated: November 25, 2003

Respectfully submitted,

By   
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